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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

*(Use as many sheets as necessary)*

Sheet	1	of	2
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**Complete if Known**

Application Number	10/599,227
Filing Date	09/22/2006
First Named Inventor	POWER, Joan F.
Art Unit	
Examiner Name	
Attorney Docket Number	773/14555.3

## U. S. PATENT DOCUMENTS

[illegible]

## FOREIGN PATENT DOCUMENTS

[illegible]

**Examiner  
Signature**

Date  
Considered

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<b>Sheet</b>	2	<b>of</b>	2	<b>Attorney Docket Number</b>	773/14555.3

**NON PATENT LITERATURE DOCUMENTS**

Examiner Initials*	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
	C1	FU, S.W. et al., "Broadband Light Profile Microscopy: A Rapid and Direct Method for Thin Film Depth Imaging", :96-104	
	C2	POWER, Joan F. et al., "Longitudinal Light Profile Microscopy: A New Method for Seeing Below the Surfaces of...", Applied Spectroscopy (1999) Vol. 53(12):1507-1519	
	C3	POWER, Joan F. et al., "Dual Beam Light Profile Microscopy: A New Technique for Optical...", Applied Spectroscopy (2004) Vol. 58(2):166-178	
	C4	POWER, J.F., "Fresnel diffraction model for the point spread of a laser light profile microscope (LPM)", Appl. Phys. B 78 (2004), pp. 693-703	
	C5	SMITH, Warren J., Modern Optical Engineering: The Design of Optical Systems, Second Edition, 1990, pp. 270-278, McGraw-Hill, New York.	

<b>Examiner Signature</b>		<b>Date Considered</b>	
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